

OPTICAL PHYSICS

Electronic control of optical tweezers using space-time-wavelength mapping

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We present a new approach for electronic control of optical tweezers by using space-time-wavelength mapping (STWM), a technique that uses time-domain modulation to control local intensity values and hence the resulting optical force in space. The proposed technique enables direct control of magnitude, location, and polarity of force hot spots created by Lorentz force (gradient force). In this paper we develop an analytical formulation of the proposed STWM technique for optical tweezing. In the case study presented here we show that 150 fs optical pulses are dispersed in time and space to achieve a focused elliptical beam that is ~20 μ m long and ~2 μ m wide. By choosing the appropriate RF waveform and electro-optic modulator we can generate multiple hot spots with >200 pN force per pulse. © 2016 Optical Society of America

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1. INTRODUCTION

Acceleration and trapping of organic and inorganic particles using optical forces, a phenomenon referred to as optical tweezing, first demonstrated by Ashkin [1], has found a wide range of applications, especially in the biosciences [2-5]. The key component in optical tweezing was the generation of high optical-intensity beams that became feasible with the advent of lasers [6–9]. With coherent laser beams and high numerical aperture lenses, it is possible to induce optical forces on dielectric particles at the focal spot. The optical forces arise due to the transfer of momentum from the scattering of incident photons and have traditionally been grouped into two categories: (a) scattering force in the direction of light propagation and (b) gradient force, whose magnitude and direction depend on the spatial light intensity gradient [10]. Ashkin's seminal work showed that large enough gradient forces could be achieved using a single laser beam, which could overcome the scattering force and accelerate particles along an intensity gradient [11]. Apart from single-beam experiments there has been growing literature on double-beam optical trapping following Ashkin's observations [9,12-15]. While the scattering force does not lend itself to direct manipulation, there are various ways of manipulating the intensity gradient, and hence of controlling the gradient force, at the focal plane. In the Rayleigh scattering regime in particular, the gradient force is more significant and has been utilized to trap sub-wavelength particles. This opened up possibilities of manipulating the intensity gradient of a laser beam to manipulate particles,

leading to applications in microfluidic systems, cell sorting, and characterization of microorganisms. To control the gradient force the intensity gradient is traditionally manipulated by mechanically steering multiple parallel beams focused onto a narrow region (~50 μ m × ~5 μ m) [16]. However, to provide greater flexibility and precision, an entirely electronic setup that does not involve any moving parts is more desirable for optical micromanipulation.

In contrast to mechanical beam steering, holographic lenses appeared as an alternative approach to electronically control the intensity gradient at the focal plane and led to the development of holographic optical tweezers (HOTs) [17-21]. In a HOT setup a computer-controlled diffractive optical element is used to modulate the phase front of a laser beam before feeding it into a conventional tweezer. Such techniques typically use liquid-crystal spatial-light modulators (SLM) to create a pixel array of intended phase shifts that are then imposed on the beam at the corresponding pixels. By using different configurations of phase-shift arrays, one is able to control the 3D location of optical traps at the focal volume. Polarization control has also been demonstrated using the phase-shift configurations imposed by the SLM, thereby controlling the spin angular momentum of the traps in addition to their spatial location [22]. While HOTs achieve electronic control over a grid of optical traps to some extent, the technique is challenged by the confinement of optical traps to discrete spots as opposed to the ability to manipulate an extended continuous-intensity landscape [18]. The lack of direct control over the intensity profile gives rise to

inhomogeneity in the intensities of resulting traps and produces undesired intensity peaks known as ghost traps, which are strong enough to trap particles at unwanted locations [19,20, 23]. Multiple approaches have been proposed to suppress ghost traps, including random mask encoding [21,24], reduction of symmetry of the trapping pattern [19], and blocking the zeroth order of diffraction and corresponding ghost traps [20]. Overall, each solution has its pros and cons, and trade-offs exist between various factors such as diffraction efficiency, computational complexity, loss of functionality, power requirement, feasible number of traps, persistent ghost traps, etc.

Here we introduce electronic control of optical tweezing by using space-time-wavelength mapping (STWM) technology [25]. We show that STWM is a powerful approach for creating desired intensity gradients in a 2D focal plane and for providing direct control of the force field acting on particles. This technique has previously been utilized for real-time imaging and detection of microparticles, real-time wide-field microscopy, and arbitrary waveform generation. It has also been utilized in photonic time-stretched analog-to-digital converters, in waveform digitizers, and in investigation of optical rogue waves [26–35]. In this paper we build on our previous study [25] and present further details and applications of the STWM technique in optical tweezing. In this technique time-domain modulation of power spectral density is used to manipulate the intensity gradient at the focal plane of a laser beam, which in turn controls the 2D force profile at the focal plane of the beam. Time-domain modulation is translated onto space domain using a diffraction grating. Using this method we demonstrate that commercial femtosecond pulses can generate >200 pN optical force hot spots, whose polarity and location along the focal plane can be controlled to achieve numerous applications such as cell stretching or particle sorting. The amount of force can be controlled by chirped pulse amplification without any nonlinear distortion. Electro-optic modulation of power spectral density allows tuning of local intensity at the focal plane for greater control and generating attractive and repulsive forces between particles at specific spots as depicted in Fig. 1.

Through the ability to directly manipulate a continuous landscape, this technique has the potential to overcome the limitations of HOTs discussed above while allowing greater and more direct electronic control of optical traps. STWM eliminates the issue of unwanted inhomogeneity among produced traps while not compromising efficiency. We also show that the proposed technique can be easily tailored to 1D and 2D applications by using diffractive optics such as gratings and virtually imaged phased arrays (VIPA) [36].

2. MODELING SETUP AND THEORY

To demonstrate the feasibility of optical tweezing by using STWM we develop our analysis based on the following realistic experimental setup as illustrated in Fig. 2. The optical tweezer is driven by a fiber laser at 1550 nm that produces 150 fs pulses with \sim 20 kW peak power. These values correspond to a laser with \sim 100 mW average power at 50 MHz repetition rate. The laser beam then propagates through a dispersive medium with \sim 100 ps/nm chromatic dispersion to broaden the optical pulse



Fig. 1. Particles experiencing gradient force at various spots on the focal plane of the beam (particle size has been scaled up for illustration).

width to ~ 2 ns at the full width half-maximum point. Hence, the dispersive propagation creates a time-wavelength mapping where 1 nm wavelength separation corresponds to 100 ps separation in time domain. Dispersed pulses are then passed through an electro-optic modulator to manipulate the power spectral density of the laser as desired by using RF waveforms. Here we assume no losses in components and that nonlinear distortion is absent in dispersive fiber. In practice it is possible to start with a lower peak power and add a chirped pulse amplification to compensate losses and eliminate distortion. The time-wavelength mapped pulses are then coupled to a diffraction grating with 600 lines/mm groove density and a cylindrical lens to create space-wavelength mapping. Finally, we use a $60 \times$ microscope objective to generate a ~20 µm long and $\sim 2 \ \mu m$ wide elliptical focal spot. After time-wavelength mapping, the diffraction grating provides a space-wavelength mapping of 1 μ m/nm at the focal plane.

Through STWM, we obtain a desired wavelengthdependent intensity profile of $I(\lambda(x, t))$. We develop opticalforce calculations based on this intensity distribution at the focal plane (z = 0). In particular we only assume optical forces in the lateral direction and ignore the force components in the axial direction. We start with a Gaussian beam A(t) = $A_0 \exp[-(1/2)(t/T_0)^2]$. Through time-wavelength mapping and RF modulation, we generate a field profile of E(t) = $A_{disp}(t)e^{j\omega t}e^{j\varphi(t)}f_{RF}(t)$ where $A_{disp}(t)$ is the dispersed pulse amplitude, ω is the angular frequency, $\varphi(t)$ is the timedependent phase or chirp, and $f_{RF}(t)$ is the applied RF modulation. This field corresponds to the optical-power profile

$$P(t) = P_{in}(t) f_{RF}^{2}(t)$$

= $P_{in}(t) \left[\frac{1}{2} + \frac{1}{2} \cos \left(\frac{\pi}{V_{\pi}} (V_{bias} + v_{RF}(t)) \right) \right],$ (1)

where the input power $P_{\rm in}(t) = (A_{\rm disp}(t))^2$, V_{π} is the halfwave voltage of the modulator, $V_{\rm bias}$ is the DC bias voltage, and $v_{\rm RF}(t)$ is the applied RF waveform. By manipulating $v_{\rm RF}(t)$ using an arbitrary waveform generator, we can control the power spectral density of the laser emerging from the electro-optic modulator.



Fig. 2. Proposed experimental setup. A 150 fs laser with 50 MHz repetition rate undergoes dispersion in time and is then modulated in time domain, and simultaneously in wavelength domain, using arbitrary RF waveforms fed to an electro-optic modulator. The modulated power spectral density is then mapped onto space domain using a diffraction grating. A cylindrical lens and a microscope objective then focus the diffracted beam onto a tight focal spot $(20 \times 10 \ \mu\text{m})$ for optical manipulation of particles.

The aggregate intensity profile of all wavelengths after the space-wavelength mapping, i.e., after the diffraction grating and a Fourier lens, can be formulated as [29]

$$I(x,\lambda) = \sum_{i} \frac{P_{i}}{(f\lambda_{i})^{2}} \exp\left[-\left(\frac{2\pi w(x-x_{i})}{f\lambda_{i}}\right)^{2}\right].$$
 (2)

Here, *w* is the spot size of the beam, *f* is the focal length of the Fourier lens, P_i represents the peak power carried by wavelength λ_i in the spectrum, and $x_i \approx G_{\beta}f(\lambda_i - \lambda_c)$ is the relative position of the first-order diffraction peak for the wavelength λ_i with respect to the central wavelength λ_c . $G_{\beta} = G/\cos(\beta)$ is the effective groove density of the diffraction grating shown in Fig. 2, which is defined as a function of groove density *G* and the first-order diffraction angle β . For a beam with wavelength λ , and incident angle α , the first-order diffraction angle β is given by the grating equation $\sin(\alpha) + \sin(\beta) = \lambda G$, which reduces to $2 \sin(\beta) = \lambda G$ when $\alpha = \beta$ in a Littrow configuration [29].

To develop a formulation for the optical force at the focal plane we assume operation under the Rayleigh scattering limit and that the particles are polarizable, such as dielectric particles. The gradient force from a laser beam acting on a particle is proportional to the light-intensity gradient and it can be derived from the basic formulation of Lorentz force [37]:

$$F = \frac{1}{2}\alpha \nabla E^2.$$
 (3)

Incorporating proportionality constants we get

$$F(r) = \frac{2\pi n_0 b^3}{c} \left(\frac{m^2 - 1}{m^2 + 2}\right) \nabla I(r),$$
 (4)

where $m = n_1/n_0$ is the relative refractive index of the particle (where n_1 is the refractive index of the particle and n_0 is the refractive index of the surrounding medium), *b* is the radius of the particle, *c* is the speed of light, and *r* is the radial distance from the beam axis.

Taking the gradient of intensity in Eq. (2), with respect to the radial distance, we get Eq. (5):

$$\nabla I(x) = \frac{\partial I(x)}{\partial x}$$

= $-\sum_{i} \frac{8\pi^2 w^2 (x - x_i)}{(f\lambda_i)^4} P_i \exp\left[-\left(\frac{2\pi w(x - x_i)}{f\lambda_i}\right)^2\right].$
(5)

Here we have assumed that we are at the focal plane and that the beam width is the spot size at the focus, i.e., $w = w_0$ for z = 0, z being the direction of propagation of the laser. Substituting Eq. (5) in Eq. (4) we get an expression for the aggregate optical force along x as shown in Eq. (6):

$$F(x) = -\frac{16n_0 w^2 \pi^3 b^3}{c} \left(\frac{m^2 - 1}{m^2 + 2}\right) \\ \times \sum_i \frac{(x - x_i)}{(f\lambda_i)^4} P_i \exp\left[-\left(\frac{2\pi w(x - x_i)}{f\lambda_i}\right)^2\right].$$
 (6)

Note that in Eq. (6) we have defined the positive x direction to be the direction of positive force. Also, Eq. (6) represents a direct relationship between the applied RF modulation and the force profile at the focal plane. RF modulation controls the power spectral density P_i in Eq. (6), thus modulating the beam intensity profile and allowing direct control of the force profile F(x).

3. RESULTS AND APPLICATIONS

Figure 3 illustrates the intensity profiles and optical-force contours acting on particles for three different RF modulation signals. The modulator is biased at the quadrature point and supplied with RF pulses of peak-to-peak voltage, $v_{RF_PP} = \gamma \cdot V_{\pi}$, where the amplitude factor γ is controlled by the arbitrary waveform generator. In the first row of Fig. 3 we present the case when there is no RF signal [Fig. 3(a)]. As expected we generate a pure elliptical beam that produces a force contour that traps the particle along the central axis of the beam. Effectively, for a beam of size 20 × 2 µm, the particle is trapped along a line-shaped well with dimensions 15 × 1.5 µm as shown in Figs. 3(b) and 3(c). In the second row of Fig. 3 we apply a 2 ns wide pulsed RF



Fig. 3. Different RF waveforms create different intensity profiles and hence can be used to produce different 2D force profiles. Figures on the left column (a), (d), and (g) show RF waveforms used to modulate the intensity. The middle column (b), (e), and (h) shows intensity profiles corresponding to each RF waveform, and the right column (c), (f), and (i) shows corresponding force contours arising from each intensity profile. Hot spots or points of maximum force can be maneuvered over the focal plane by selecting an appropriate RF waveform.

signal where peak-to-peak voltage $v_{RF PP} = 1V_{\pi}$ [Fig. 3(d)]. The RF pulse wave in Fig. 3(d) creates two $3 \times 2 \mu m$ intensity spikes separated by a 4 μ m null region as depicted in Fig. 3(e). Each intensity spike creates a 4×1 µm trapping region as illustrated in Fig. 3(f). Similarly, Figs. 3(g)-3(i), in the third row of Fig. 3, illustrate the RF waveform and generation of three intensity spikes and three force hot spots. Here, the RF waveform has two pulses, each of width 1 ns, separated by 2 ns [Fig. 3(g)]. It cuts through the beam at two places leaving three intensity spikes, each measuring $2 \times 2 \mu m$ [Fig. 3(h)]. These three intensity spikes in turn generate three force hot spots, each of which can trap particles within a $4 \times 1 \mu m$ region. Beams with wider spectra can be used to produce a higher number of hot spots along the ellipse of the focus. The maximum force generated per pulse at the hot spots is ~200 pN for 100 nm particle radius. By using different waveforms we can extend the number of hot spots and control the relative strength and position of optical forces acting on polarizable particles. In these calculations we assume that the rise time of RF pulses is >200 ps, which requires the RF bandwidth of the arbitrary waveform generator to be well below 10 GHz.

One of the clear advantages of the proposed method is the precise location control of force fields without altering the rest of the continuous force landscape. The center of the force field is determined by the location of the intensity spikes. Hence, we can change the pulse width and RF voltage to determine the exact location of trap centers. For instance, for the RF signal shown is Fig. 3(d), a pulse width of $\tau_1 = 2$ ns corresponds to a distance $d_1 = 6 \mu m$ between force hot spots, and a pulse width of $\tau_2 = 4$ ns corresponds to a distance $d_2 = 12 \mu m$ as illustrated in Fig. 4 by the red and blue curves, respectively. The precision of this technique depends on the RF bandwidth. For a bandwidth of 10 GHz, the narrowest RF pulse possible is <0.1 ns, which results in a minimum achievable separated by, for example, 5 μm can be brought to within 0.5 μm of each other using this approach.

In addition to location control of hot spots, Fig. 5 illustrates how we can also alter the direction of the force at the hot spots by generating suitable intensity profiles through RF modulation. To achieve this we need the ability to change the sign of the intensity gradient. A default super-Gaussian beam profile [Fig. 5(a)] results in a trap located at the beam center [Fig. 5(c)] due to a positive intensity gradient followed by a negative intensity gradient [Fig. 5(b)]. As depicted in Fig. 5(b), a positive gradient ($\sim + 1.5$ W/nm) produces a positive force spike (~ 250 pN) followed by a zero-force region spanning ~ 5 µm. Then a negative gradient ($\sim - 1.5$ W/nm) creates a negative



Fig. 4. Illustrating location control of hot spots. (a) Modulated power distribution and (b) generated force profile along *x*. The width of the null region τ in the modulated power distribution in (a) can be varied as desired to control the distance *d* between trap centers in (b). Here, τ_1 and τ_2 correspond to d_1 and d_2 , respectively.

force spike (~ -250 pN). A particle positioned at each of these spikes will experience a force pulling them toward the center, creating an attractive force between the particles. In general, the precise control of DC bias and RF waveform facilitates the generation of arbitrary force polarity and magnitude. Such pulse profiles are particularly useful for bio applications that compress cells. However, to make the proposed method compatible with bio applications, operation wavelength has to be at near IR or visible to avoid water absorption. The method presented in this paper can be tailored for pulsed near-IR lasers, such as modelocked Ti-sapphire lasers, if bio applications are being pursued.

To reverse the force direction we can modulate the intensity at the beam center and create negative gradients. For instance, a pulsed RF waveform, such as the one shown in Fig. 5(d), can be used to create a power dip in the middle [Fig. 5(e)], essentially producing a negative gradient followed by a positive gradient at the beam center. This results in an inverted force profile [Fig. 5(f) compared to 5(c)] where a negative force spike is followed by a positive one with a zero-force region in between. In this particular example we used a 2 ns wide pulsed RF waveform with a peak-to-peak amplitude of $0.5V_{\pi}$ to create a negative gradient of ~ -0.5 W/nm followed by a zero gradient and then a positive gradient of $\sim +0.5$ W/nm. Figure 5(f) shows the resulting force profile, which is composed of a negative force spike $(\sim -190 \text{ pN})$ and a positive force spike $(\sim +190 \text{ pN})$ separated by a zero-force region spanning $\sim 4 \,\mu$ m. The configuration in Fig. 5(f) can be used to repel particles away from the center of the beam. Similarly, we can use more complicated RF waveforms to generate compressive and repelling forces or control multiple particles at the same time as shown in Figs. 5(g)-5(i). Here we use the RF waveform shown in Fig. 5(g) to modulate the power spectral density such that the power rises in two discrete steps creating two successive positive gradients. First the peak power is increased from 0 W at ~1541 nm to a steady value of ~0.7 W at



Fig. 5. Demonstrating polarity control of hot spots. The green curves on the left column (a), (d), and (g) show the normalized RF waveform. The middle column (b), (e), and (h) shows the corresponding modulated power profile for each RF waveform. The right column (c), (f), and (i) shows the desired force profiles generated using the applied modulation. Different sequences of positive and negative power gradients result in different arrangements of polarities (i.e., push or pull) of the generated force spikes, creating attractive [top row: (a), (b), and (c)], repulsive [middle row: (d), (e), and (f)], and other arbitrary [bottom row: (g), (h), and (i)] force configurations.

~1543 nm, which is maintained until ~1549 nm as depicted in Fig. 5(h). The power profile in Fig. 5(h) starts with a positive gradient of ~ + 0.35 W/nm, which produces a positive force peak of ~ + 140 pN followed by a zero-force region spanning ~4 μ m as shown in Fig. 5(i). Then, instead of a power fall off as characteristic of regular pulses, the peak power undergoes a second increase from ~0.7 W at ~1549 nm to ~1.4 W at ~1550 nm with a gradient of ~ + 0.7 W/nm. This is followed by a steady region where it remains at 1.4 W until ~1556 nm before sliding down to zero with a negative gradient of ~ -0.47 W/nm as illustrated in Fig. 5(h). Thus we obtain an additional positive force peak of ~ + 150 pN due to the second rise in peak power followed by a zero-force region of width ~6 μ m and a negative spike of ~ - 150 pN as depicted in Fig. 5(i).

The proposed technique can be extended to create a 2D grid of traps or any other arbitrary 2D pattern by treating the power spectral distribution as a 2D matrix and modulating each row of the matrix with a desired RF waveform. One way to create and control a 2D force field is to use a 2D spatial disperser to generate a 2D spectral shower using two orthogonally oriented 1D spatial dispersers: a diffraction grating and a VIPA as prescribed in literature [36]. The angular dispersion by a VIPA is 10-20 times larger than those of common diffraction gratings, which have a Blaze angle of $\sim 30^{\circ}$ [38]. The VIPA employs a thin plate of glass and a semi-cylindrical lens (C lens). The input light is line focused with the semi-cylindrical lens into the glass plate. The collimated light then emerges on the other side of the plate where the angle of propagation is dependent on the wavelength [38]. When it comes to 2D manipulation, holographic optical tweezers are typically limited to a grid of optical traps. While our approach has no such limitation, it is useful to mimic such a grid for existing applications. Using the proposed technique each trapping region and its associated force spikes take up a minimum area of $7 \times 4 \mu m$, meaning a ~1200 μm^2 area can accommodate ~45 traps as shown in Fig. 6. In addition to a rigid grid of traps (Fig. 6) we can achieve any arbitrary pattern with extended areas of high intensity, leading to bigger force hot spots whose location and polarity can be precisely controlled over the entire 2D plane as described above and illustrated in Fig. 7. This opens up new possibilities and further prospects stemming from the greater flexibility and control over the entire landscape.



Fig. 6. Left: illustration of an intensity profile that can be obtained by using a 2D dispersive system in order to create a grid of optical traps. Right: corresponding 2D grid of force hot spots that can be achieved using the intensity profile.



Fig. 7. Demonstrating flexible control over the entire continuous 2D landscape. Left: an arbitrary 2D intensity profile obtained using the proposed technique. Right: corresponding 2D force profile.

4. DISCUSSION AND SUMMARY

We have presented a method to achieve electronically controlled force profiles for optical-tweezing applications by extending the idea of STWM. The proposed approach can generate a continuous force profile at the focal point where polarity, location, and magnitude can be controlled precisely by using time-domain electro-optic modulation. The created hot spots can be actively tuned to accelerate particles in a particular direction, to maneuver them along the 2D focal plane, and to create more complex scenarios for a wide range of applications, especially in the biosciences.

One major obstacle that continues to be a challenge in optical manipulation is the diffraction limit when working with nanometer-sized objects. Techniques in plasmon nano-optics exploit surface plasmon resonances supported by metallic nanostructures to effectively concentrate evanescent fields well beyond the diffraction limit [39-48]. The STWM technique proposed here, however, uses time-stretch to overcome the diffraction limit. Precision of the proposed technique can be enhanced by using a wider RF bandwidth or by increasing the optical bandwidth of the laser with an appropriate dispersion value. Overall, one needs to consider trade-offs between dispersion, RF bandwidth, spectral width, power requirement, and spatial precision in order to implement the STWM approach. Future work building on this study will involve conducting the proposed experiment to corroborate the theory and simulation with experimental results and further investigation into the capabilities and limitations of the proposed method. In particular, the analysis will be extended by considering scattering forces in the axial direction, which have been ignored in the current model.

REFERENCES

- A. Ashkin, "Acceleration and trapping of particles by radiation pressure," Phys. Rev. Lett. 24, 156–159 (1970).
- J. Enger, M. Goksör, K. Ramser, P. Hagberg, and D. Hanstorp, "Optical tweezers applied to a microfluidic system," Lab Chip 4, 196–200 (2004).
- M. M. Wang, E. Tu, D. E. Raymond, J. M. Yang, H. Zhang, N. Hagen, B. Dees, E. M. Mercer, A. H. Forster, I. Kariv, P. J. Marchand, and W. F. Butler, "Microfluidic sorting of mammalian cells by optical force switching," Nat. Biotechnol. 23, 83–87 (2004).
- J. Jass, S. Schedin, E. Fällman, J. Ohlsson, U. J. Nilsson, B. E. Uhlin, and O. Axner, "Physical properties of Escherichia coli P pili measured by optical tweezers," Biophys. J. 87, 4271–4283 (2004).

- M. P. MacDonald, G. C. Spalding, and K. Dholakia, "Microfluidic sorting in an optical lattice," Nature 426, 421–424 (2003).
- R. T. Beyer, "Radiation pressure—the history of a mislabeled tensor," J. Acoust. Soc. Am. 63, 1025–1030 (1978).
- Frankel, "Corpuscular optics and the wave theory of light: the science and politics of a revolution in physics," Soc. Stud. Sci. 6, 141–184 (1976).
- T. A. Nieminen, N. du Preez-Wilkinson, A. B. Stilgoe, V. L. Y. Loke, A. A. M. Bui, and H. Rubinsztein-Dunlop, "Optical tweezers: theory and modelling," J. Quant. Spectrosc. Radiat. Transfer **146**, 59–80 (2014).
- G. Roosen and C. Imbert, "Optical levitation by means of two horizontal laser beams: a theoretical and experimental study," Phys. Lett. A 59, 6–8 (1976).
- K. C. Neuman and S. M. Block, "Optical trapping," Rev. Sci. Instrum. 75, 2787–2809 (2004).
- A. Ashkin, J. M. Dziedzic, J. E. Bjorkholm, and S. Chu, "Observation of a single-beam gradient force optical trap for dielectric particles," Opt. Lett. 11, 288–290 (1986).
- J. P. Barton, D. R. Alexander, and S. A. Schaub, "Internal and nearsurface electromagnetic fields for a spherical particle irradiated by a focused laser beam," J. Appl. Phys. 64, 1632–1639 (1988).
- J. P. Barton, D. R. Alexander, and S. A. Schaub, "Theoretical determination of net radiation force and torque for a spherical particle illuminated by a focused laser beam," J. Appl. Phys. 66, 4594–4602 (1989).
- F. Guilloteau, G. Gréhan, and G. Gouesbet, "Optical levitation experiments to assess the validity of the generalized Lorenz-Mie theory," Appl. Opt. 31, 2942–2951 (1992).
- G. Grehan and G. Gouesbet, "Optical levitation of a single particle to study the theory of the quasi-elastic scattering of light," Appl. Opt. 19, 2485–2487 (1980).
- A. B. Stilgoe, N. R. Heckenberg, T. A. Nieminen, and H. Rubinsztein-Dunlop, "Phase-transition-like properties of double-beam optical tweezers," Phys. Rev. Lett. **107**, 248101 (2011).
- J. E. Curtis, B. A. Koss, and D. G. Grier, "Dynamic holographic optical tweezers," Opt. Commun. 207, 169–175 (2002).
- D. M. Woerdemann, "Holographic optical tweezers," in *Structured Light Fields* (Springer, 2012), pp. 95–116.
- J. E. Curtis, C. H. Schmitz, and J. P. Spatz, "Symmetry dependence of holograms for optical trapping," Opt. Lett. 30, 2086–2088 (2005).
- M. Polin, K. Ladavac, S.-H. Lee, Y. Roichman, and D. G. Grier, "Optimized holographic optical traps," Opt. Express 13, 5831–5845 (2005).
- M. Montes-Usategui, E. Pleguezuelos, J. Andilla, and E. Martín-Badosa, "Fast generation of holographic optical tweezers by random mask encoding of Fourier components," Opt. Express 14, 2101–2107 (2006).
- D. Preece, S. Keen, E. Botvinick, R. Bowman, M. Padgett, and J. Leach, "Independent polarisation control of multiple optical traps," Opt. Express 16, 15897–15902 (2008).
- C. Hesseling, M. Woerdemann, A. Hermerschmidt, and C. Denz, "Controlling ghost traps in holographic optical tweezers," Opt. Lett. 36, 3657–3659 (2011).
- J. Mas, M. S. Roth, E. Martín-Badosa, and M. Montes-Usategui, "Adding functionalities to precomputed holograms with random mask multiplexing in holographic optical tweezers," Appl. Opt. 50, 1417– 1424 (2011).
- S. Rahman, R. Torun, Q. Zhao, T. Atasever, and O. Boyraz, "Electronically-controlled optical tweezing using space-timewavelength mapping," Proc. SPIE **9581**, 95810E (2015).

- F. Qian, Q. Song, E. Tien, S. K. Kalyoncu, and O. Boyraz, "Real-time optical imaging and tracking of micron-sized particles," Opt. Commun. 282, 4672–4675 (2009).
- K. K. Tsia, K. Goda, D. Capewell, and B. Jalali, "Performance of serial time-encoded amplified microscope," Opt. Express 18, 10016–10028 (2010).
- D. R. Solli, J. Chou, and B. Jalali, "Amplified wavelength-time transformation for real-time spectroscopy," Nat. Photonics 2, 48–51 (2008).
- S. K. Kalyoncu, Y. Huang, Q. Song, and O. Boyraz, "Analytical study on arbitrary waveform generation by MEMS micro mirror arrays," Opt. Express 20, 27542–27553 (2012).
- Y. Han, O. Boyraz, and B. Jalali, "Ultrawide-band photonic timestretch a/D converter employing phase diversity," IEEE Trans. Microwave Theory Tech. 53, 1404–1408 (2005).
- F. Coppinger, A. S. Bhushan, and B. Jalali, "Photonic time stretch and its application to analog-to-digital conversion," IEEE Trans. Microw. Theory Tech. 47, 1309–1314 (1999).
- Y. Han and B. Jalali, "Photonic time-stretched analog-to-digital converter: fundamental concepts and practical considerations," J. Lightwave Technol. 21, 3085–3103 (2003).
- Y. Han, O. Boyraz, and B. Jalali, "Tera-sample per second real-time waveform digitizer," Appl. Phys. Lett. 87, 241116 (2005).
- O. B. Jason Chou, "Femtosecond real-time single-shot digitizer," Appl. Phys. Lett. 91, 161105 (2007).
- D. R. Solli, C. Ropers, P. Koonath, and B. Jalali, "Optical rogue waves," Nature 450, 1054–1057 (2007).
- P. Metz, J. Adam, M. Gerken, and B. Jalali, "Compact, transmissive two-dimensional spatial disperser design with application in simultaneous endoscopic imaging and laser microsurgery," Appl. Opt. 53, 376–382 (2014).
- Y. Harada and T. Asakura, "Radiation forces on a dielectric sphere in the Rayleigh scattering regime," Opt. Commun. 124, 529–541 (1996).
- M. Shirasaki, "Large angular dispersion by a virtually imaged phased array and its application to a wavelength demultiplexer," Opt. Lett. 21, 366–368 (1996).
- M. L. Juan, M. Righini, and R. Quidant, "Plasmon nano-optical tweezers," Nat. Photonics 5, 349–356 (2011).
- J. M. Vigoureux and D. Courjon, "Detection of nonradiative fields in light of the Heisenberg uncertainty principle and the Rayleigh criterion," Appl. Opt. 31, 3170–3177 (1992).
- 41. L. Novotny and B. Hecht, *Principles of Nano-Optics* (Cambridge, 2012).
- P. Forbrig, F. Paternò, and A. M. Pejtersen, *Excitation of Plasmons and Interband Transitions by Electrons* (Springer, 2008).
- S. A. Maier, *Plasmonics: Fundamentals and Applications* (Springer, 2007).
- W. L. Barnes, A. Dereux, and T. W. Ebbesen, "Surface plasmon subwavelength optics," Nature 424, 824–830 (2003).
- E. Ozbay, "Plasmonics: merging photonics and electronics at nanoscale dimensions," Science **311**, 189–193 (2006).
- S. Grésillon, L. Aigouy, A. C. Boccara, J. C. Rivoal, X. Quelin, C. Desmarest, P. Gadenne, V. A. Shubin, A. K. Sarychev, and V. M. Shalaev, "Experimental observation of localized optical excitations in random metal-dielectric films," Phys. Rev. Lett. 82, 4520–4523 (1999).
- K. Li, M. I. Stockman, and D. J. Bergman, "Self-similar chain of metal nanospheres as an efficient nanolens," Phys. Rev. Lett. **91**, 227402 (2003).
- M. I. Stockman, "Nanofocusing of optical energy in tapered plasmonic waveguides," Phys. Rev. Lett. 93, 137404 (2004).